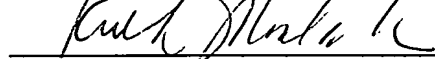


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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: JG-SU-5224/500577.20073

U.S. Application No.:

International Application No.: PCT/JP2005/006268

International Filing Date: MARCH 31, 2005

31 MARCH 2005

Priority Date Claimed: APRIL 05, 2004

04 APRIL 2004

Title of Invention: **MANUFACTURING METHOD OF SEMICONDUCTOR WAFER AND SEMICONDUCTOR WAFER MANUFACTURED BY THIS METHOD**  
Applicant(s) for (DO/EO/US): **Syужи NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI**

Mail Stop PCT  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-450

## INFORMATION DISCLOSURE STATEMENT

S I R:

Applicant herewith submits together with the simultaneously filed National Phase application of PCT/EP2003/013475, a copy of the International Search Report (PCT/ISA/210) dated May 4, 2004, citing some of the following references:

	Document Number	Date	Name and/or Country	English Translation and/or Equivalent
AA	6,495,294	12/17/2002	Yamauchi, et al.	
AL	2001-196573	07/19/2001	Japan	US 6,495,294
AM	2003-218037	07/31/2003	Japan	Abstract only

Accompanying this Information Disclosure Statement and form PTO-1449 are copies of the documents including English Abstract and US equivalent. Document AL is mentioned on page 2 of the substitute specification.


The USPTO waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting copies of US patents and US patent application publications in all U.S. applications filed after June 30, 2003. First pages of US documents only.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,

JG:ram  
12/22/05  
Tel. (212) 521-5400

Enclosures:  
Search Report (PCT/ISA/210);  
PTO-1449  
1 first page US Patents  
2 foreign documents  
2 English Abstracts

  
\_\_\_\_\_  
Jules E. Goldberg - Reg. No. 24,408  
Reed Smith LLP  
599 Lexington Avenue  
New York, NY 10022-7650

**LIST OF PRIOR ART CITED BY APPLICANT**  
(Filed on December 22, 2005)

Docket No. **JG-SU-5224/500577.20073**Applicant(s): **Syouji NOGAMI, Yukichi HORIOKA, and Shoichi YAMAUCHI**

Application No. (Int'l Appln No. PCT/JP2004/006268 31MAY05) Group:

Filed: Examiner:

**U.S. PATENT DOCUMENTS**

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	<b>AA</b>	<b>6,495,294</b>	<b>12/17/2002</b>	<b>Yamauchi, et al.</b>			
	<b>AB</b>						
	<b>AC</b>						
	<b>AD</b>						
	<b>AE</b>						
	<b>AF</b>						
	<b>AG</b>						
	<b>AH</b>						
	<b>AI</b>						
	<b>AJ</b>						
	<b>AK</b>						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES	NO
	<b>AL</b>	<b>2001-196573</b>	<b>07/19/2001</b>	<b>Japan</b>			<b>US 6,495,294</b>	
	<b>AM</b>	<b>2003-218037</b>	<b>07/31/2003</b>	<b>Japan</b>			<b>Abstract only</b>	
	<b>AN</b>							
	<b>AO</b>							
	<b>AP</b>							
	<b>AQ</b>							
	<b>AR</b>							
	<b>AS</b>							
	<b>AT</b>							

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

	<b>AX</b>	
	<b>AY</b>	
	<b>AZ</b>	

Examiner:

Date:

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.